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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/982,954	10/22/2001	Gurtej Sandhu	M4065.0353/P353-A	8784	
24998	7590 06/09/2003				
	DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP			EXAMINER	
2101 L STRE WASHINGT	ON, DC 20037-1526	· ·		MOORE, KARLA A	
			ART UNIT	PAPER NUMBER	
			1763	9	
			DATE MAILED: 06/09/2003	/.	

Please find below and/or attached an Office communication concerning this application or proceeding.

			157/
4	Application N .	Applicant(s)	,
Advisory Action	09/982,954	SANDHU ET AL.	
-	Examiner	Art Unit	
	Karla Moore	1763	
The MAILING DATE of this communication appe	ears on the c ver sheet with the	correspondence addı	ess
THE REPLY FILED 22 May 2003 FAILS TO PLACE THI Therefore, further action by the applicant is required to avinal rejection under 37 CFR 1.113 may only be either: (1) condition for allowance; (2) a timely filed Notice of Appea Examination (RCE) in compliance with 37 CFR 1.114.	oid abandonment of this applic ) a timely filed amendment whic	ation. A proper reply th places the applicat	to a ion in
PERIOD FOR RE	EPLY [check either a) or b)]		
a) The period for reply expires 3 months from the mailing date			
b) The period for reply expires on: (1) the mailing date of this A no event, however, will the statutory period for reply expire I ONLY CHECK THIS BOX WHEN THE FIRST REPLY WAS 706.07(f).	ater than SIX MONTHS from the mailing FILED WITHIN TWO MONTHS OF T	ng date of the final rejection HE FINAL REJECTION.	on. See MPEP
Extensions of time may be obtained under 37 CFR 1.136(a). The ee have been filed is the date for purposes of determining the period of ee under 37 CFR 1.17(a) is calculated from: (1) the expiration date of 2) as set forth in (b) above, if checked. Any reply received by the Officially filed, may reduce any earned patent term adjustment. See 37 C	of extension and the corresponding amount the shortened statutory period for reply be later than three months after the ma	ount of the fee. The appropriation of the final Configuration of the final	opriate extension Office action; or
<ol> <li>A Notice of Appeal was filed on Appellant's 37 CFR 1.192(a), or any extension thereof (37 CFF</li> </ol>			
<ol><li>The proposed amendment(s) will not be entered be</li></ol>	ecause:		
(a) They raise new issues that would require further	er consideration and/or search (	see NOTE below);	
(b) they raise the issue of new matter (see Note b	elow);		
<ul><li>(c) they are not deemed to place the application in issues for appeal; and/or</li></ul>	n better form for appeal by mate	erially reducing or sin	nplifying the
(d) they present additional claims without canceli NOTE:	ng a corresponding number of f	finally rejected claims	<b>5.</b>
3. Applicant's reply has overcome the following reject	ion(s):		
4. Newly proposed or amended claim(s) would canceling the non-allowable claim(s).	•	eparate, timely filed a	amendment
5. ☐ The a) ☐ affidavit, b) ☐ exhibit, or c) ☐ request for application in condition for allowance because: See		idered but does NOT	place the
6. The affidavit or exhibit will NOT be considered becaraised by the Examiner in the final rejection.	ause it is not directed SOLELY	to issues which were	newly
7. For purposes of Appeal, the proposed amendment explanation of how the new or amended claims we			nd an
The status of the claim(s) is (or will be) as follows:			
Claim(s) allowed:			
Claim(s) objected to:			
Claim(s) rejected: <u>1-17,46 and 47</u> .			
Claim(s) withdrawn from consideration:			
8. The proposed drawing correction filed on is	a)☐ approved or b)☐ disapp	proved by the Examir	ner.
9. Note the attached Information Disclosure Statemer	nt(s)( PTO-1449) Paper No(s)		
10.⊠ Other: <u>See Continuation Sheet</u>	, , , , , , , , , , , , , , , , , , ,	_	
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## Continuation of 10. Other:

In response to Applicant's arguments,

- 1. The two showerheads, 136 and 138, indicate two different processing regions. While the prior art does not use the exact same language as the present Application, one of ordinary skill in the art would recognie with two separate showerheads, two processing can b formed with each region capable of a different process.
- 2. Admittedly, McInerney describes his apparatus as capable of processing using two incompatible gases. However, this would not preclude one from using two gases that are "compatible". There are no teachings that teach against using two "compatible gases". Further, McInerney teaches that his apparatus is capable of processing "incompatible" gases because the apparatus comprises means fo separating the adjacent processing regions. This is also the concern of the present application. Therefore one would be inclinded to look to McInerney for separation means, contrary to Applicant's argument.
- 3. Applicant argues that because using multiple processing chambers increases throughput, one would not be inclined to use the apparatus of McInerney for diffusion, as claimed. One of ordinary skill in the art would recognize that throughput is not the only paramete to be maximized in processing apparatus such as McInerney and the present invention. One of ordinary skill in the art would also consider other parameters such as quality of the substrate produced and would aim for a balance between these two parameters in substrate processing. In some case, multiple processing chambers are necessary, as is well known in the art.
- 4. At column 8, rows 36-46, McInerney teaches that the inert gas curtain does in fact assist in maintaining separation of reaction gases, contrary to Applicant's interpretation of the reference.
- 5. As noted in the previous office action, Fong teaches transferring a substrate to a separate processing region to drive in dopants at column 41, row 61 through column 42, line 12. Fong teaches that there are alternatives for the processing step of driving in dopants. On of them is transferring a substrate to a different region.
- 6. Applicant further argues that Gattuso is not combinable because of it's teaching that "a significant amount of inert gas within the chamber can interfere with the deposition process". The gas curtain of McInerney is supplied between each of the stations. It only "interacts"or "interferes" to the extent that it separates any gas that may have migrated out of a station. It does not interfere with the deposition process. Additionally, McInerney fails to teach that a "significant" amount of gas must be used to form the inert gas curtain.
- 7. Applicant also argues that providing an inert gas curtain at a higher pressure than the reaction gases in McInerney would annul the pressure gradient of the vertically flowing reaction gases and prohibit the gases from being exhausted through the exhaust pot. Again, Examiner disagrees, an inert gas curtain is provided at a location adjacent to the reaction gases to effect separation, the inert gas curtain does not interfere with the vertical pressure gradient formed by downwardly flowing reaction gases it was meant to separate.
- 8. Applicant's argument with respect to the use of a "non-reactive" gas vsersus a "reactive" gas versus an "incopmpatible" gas are based on an intended use. The apparatus of McInerney is not structurally different as mentioned in the previous office action.
- 9. With respect to Applicant's argument that Hartig is nonanalogous art, it has been held that a prior art reference must either be in the field of applicant's endeavor or, if not, then be reasonably pertinent to the particular problem with which the applicant was concerned, in order to be relied upon as a basis for rejection of the claimed invention. See In re Oetiker, 977 F.2d 1443, 24 USPQ2d 1443 (Fed. Cir. 1992). In this case, similar to McInerney and Gattuso, Hartig is a multiple station processing apparatus, concerned with separation of adjacent stations and the processing gases contained therein. With respect to Applicant's argument that McInerney teaches away from separate exhaust ports, Examiner disagrees. Admittedly, McInerney does not teach separate exhaust ports. However, "not teaching" a feature is not the same as "teaching away" from a feature. McInerney provides no reason why providing separate exhaust ports would ruin the invention.